



Attorney Docket No. 59521 (48229)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Hiroyuki Shimada

EXAMINER: Chen Kin Chan

U.S.S.N.: 10/678,994

GROUP ART UNIT: 1765

FILED: October 3, 2003

CONFIRMATION NO.: 8918

FOR: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE  
INCLUDING ETCHING A CONDUCTIVE LAYER BY USING A GAS  
INCLUDING  $\text{SiCl}_4$  and  $\text{NF}_3$

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By

  
Nicole M. McKinnon

.....  
Mail Stop AF  
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P.O. Box 1450  
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Sir:

AMENDMENT AFTER FINAL

In response to the Office Action dated October 31, 2005, Applicant submits the following amendment.